Helium atom diffraction measurements of the surface structure and vibrational dynamics of CH$_3$–Si(111) and CD$_3$–Si(111) surfaces

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The surface structure and vibrational dynamics of CH$_3$–Si(111) and CD$_3$–Si(111) surfaces were measured using helium atom scattering. The elastic diffraction patterns exhibited a lattice constant of 3.82 Å, in accordance with the spacing of the silicon underlayer. The excellent quality of the observed diffraction patterns, along with minimal diffuse background, indicated a high degree of long-range ordering and a low defect density for this interface. The vibrational dynamics were investigated by measurement of the Debye–Waller attenuation of the elastic diffraction peaks as the surface temperature was increased. The angular dependence of the specular ($\theta_r=\theta_t$) decay revealed perpendicular mean-square displacements of 1.0 $\times$ 10$^{-5}$ Å$^2$ K$^{-1}$ for the CH$_3$–Si(111) surface and 1.2 $\times$ 10$^{-5}$ Å$^2$ K$^{-1}$ for the CD$_3$–Si(111) surface, and a He-surface attractive well depth of $\sim$7 meV. The effective surface Debye temperatures were calculated to be 983 K for the CH$_3$–Si(111) surface and 824 K for the CD$_3$–Si(111) surface. These relatively large Debye temperatures suggest that collisional energy accommodation at the surface occurs primarily through the Si–C local molecular modes. The parallel mean-square displacements were 7.1 $\times$ 10$^{-4}$ and 7.2 $\times$ 10$^{-4}$ Å$^2$ K$^{-1}$ for the CH$_3$–Si(111) and CD$_3$–Si(111) surfaces, respectively. The observed increase in thermal motion is consistent with the interaction between the helium atoms and Si–CH$_3$ bonding modes. These experiments have thus yielded detailed information on the dynamical properties of these robust and technologically interesting semiconductor interfaces. © 2010 American Institute of Physics. [doi:10.1063/1.3483465]

I. INTRODUCTION

Surface functionalization is a powerful method for tailoring the physical and chemical properties of interfaces. Several synthetic routes have allowed the fabrication of high-coverage atomic and molecular layers on a variety of metallic and semiconducting surfaces,$^1$ 5 with self-assembled monolayers (SAMs) produced by thiol linkages to Au(111) comprising the most ubiquitous and advanced methodology.$^{2,6–15}$ Such SAMs have evolved into a sophisticated technology with applications in nanoscience and biotechnology.$^{15–19}$ With the success of the SAM/Au system, strategies for creating molecular layers on semiconductor substrates have been the focus of ongoing research. Reactive additions to the Si(100) and Si(111) surfaces have emerged as an effective method for the functionalization of semiconductor interfaces.$^{4,20–23}$

Hydrogen-terminated Si(111) surfaces are attractive substrates because they can be fabricated with large, atomically flat terraces.$^{24}$ Unfortunately, a major drawback of the H-terminated surface is that it rapidly oxidizes upon exposure to the ambient environment.$^{25}$ To protect and insulate the surface, the H–Si(111) surface can be alkylated with Grignard reagents to create an inert surface that maintains the desirable interfacial electrical properties of the H–Si(111) surface.$^{3,26,27}$ Specifically, methyl-terminated Si(111) surfaces offer a particularly robust and durable semiconductor interface for use in devices such as photodiodes and Schottky junctions.$^{28,29}$ The two-step halogenation/Grignard methylation method generates surfaces that have nearly complete coverage ($>$95%) and large, atomically flat terraces.$^{30}$ Methyl termination electrically and chemically passivates the silicon surface and, in particular, provides resistance against surface oxidation and thermal degradation. The methyl-terminated surface has been shown to be stable in air for extended periods ($>$600 hr) and to be unaffected by extreme temperatures ($\sim$700 K).$^{31,32}$

CH$_3$-terminated Si(111) has been characterized by a variety of standard surface science techniques to determine the surface’s structural, vibrational, and electronic properties. A combination of low-energy electron diffraction (LEED) and cryogenic scanning tunneling microscopy (STM) measurements have revealed that methyl termination creates a (1 $\times$ 1) surface with a methyl-methyl spacing of 3.8 Å.$^{30,33,34}$ The vibrational spectra of the CH$_3$–Si(111) surface have been measured by transmission infrared spectroscopy (TIRS) and by high-resolution electron energy loss spectroscopy (HREELS), allowing the assignment of the vibrational modes of this interface.$^{34–36}$ These spectroscopic techniques...
have provided functional group analysis and a detailed picture of the Si–C covalent bonding. A photoelectron spectroscopic study has shown that methylation creates a surface dipole, slightly shifting the silicon valence and conduction band edges at the surface. Furthermore, the low levels of midgap states measured by scanning tunneling spectroscopy attest to the high degree of electrical passivation that is provided by methyl termination. To date, although the static properties of such surfaces have been studied rather thoroughly, the dynamical properties of such systems remain largely unexplored. An understanding of the vibrational dynamics can provide insight into energy accommodation, vibrational decay pathways, and heat flow at the surface.

We describe herein a helium atom scattering (HAS) study that has revealed static and dynamical properties of the methyl-terminated Si(111) surface that are inaccessible by other techniques. HAS provides a nondestructive neutral atom probe of structure and low-energy vibrations, with unique surface sensitivity. In this work, helium atom diffraction was employed to examine the surface structure, gas-surface interaction potentials, and interfacial vibrational dynamics of CH₃- and CD₃-terminated Si(111). The surface lattice constant and average domain size of such systems was determined by analysis of the helium diffraction patterns. In addition, the thermal motion at the interface was quantified by extracting the temperature-dependent mean-square displacements perpendicular to and parallel to the surface. Using the angular dependence of the Debye–Waller factor, the helium-surface well depth and surface Debye temperatures were calculated for CH₃- and CD₃-terminated Si(111) surfaces.

II. MATERIALS AND EXPERIMENTAL METHODS

The Si(111) wafers were double-side polished, float-zone grown, and had a resistivity of 63–77 Ω cm (Silicon Quest International, Santa Clara, CA). Water was obtained from a Barnstead Nanopure system (Waltham, MA) and had a resistivity of 18.3 MΩ cm.

Si(111) surfaces were functionalized by a two-step chlorination/alkylation method. Briefly, Si wafers were cut into (1 cm × 3 cm) rectangles. Contaminants were removed from the wafer-surface by sequential rinsing with water, methanol, acetone, methanol, and finally water. Without allowing the wafer to dry, the sample was transferred to a test-tube that contained freshly prepared Piranha solution [H₂SO₄ (97 wt %): H₂O₂ (29–32 wt %), 3:1 by volume]. The solution was then heated to 100 °C for 5 min, after which the wafer was allowed to cool slowly to ambient temperature followed by a rinse with copious amounts of water.

The cleaned samples were then immersed into 6 M HF(aq) [prepared by dilution of 49% HF(aq) (semiconductor grade, Transene Co., Inc., Danvers, MA)] for 45 s, rinsed with water, and transferred to an Ar-purged solution of 11 M NH₄F(aq) (semiconductor grade, Transene Co., Inc., Danvers, MA). The NH₄F(aq) was continuously purged with Ar for the duration of the etching (10 min) and the samples were agitated periodically to prevent bubbles from adhering to the sample. This procedure is known to produce atomically flat, H-terminated Si(111) surfaces. After etching, the samples were transferred to an N₂-purged glove-box that contained less than 10 ppm of O₂.

Cl–Si(111) surfaces were prepared by transferring H–Si(111) samples to test tubes that contained saturated solutions of PCl₅ (99.998% metal basis, Alfa Aesar, Ward Hill, MA) in chlorobenzene (anhydrous, 99.8%, Sigma Aldrich, St. Louis, MO) to which a small amount of radical initiator (benzoyl peroxide, Aldrich reagent grade, 97%, Sigma Aldrich) had been added. The samples were heated to 90–95 °C for 45 min, after which they were rinsed with chlorobenzene and then with tetrahydrofuran (THF).

Directly following the chlorination, to prepare CH₃–Si(111) surfaces, the samples were transferred into a 1.0 M solution of CH₃MgCl in THF (Sigma Aldrich) and heated to 70 °C for 3 h. To prepare CD₃–Si(111) surfaces, the samples were transferred into a 3.0 M solution of CD₃MgI in diethyl ether (Sigma Aldrich) and kept at room temperature for 48 h. Following alkylation, the samples were rinsed with copious amounts of THF or diethyl ether, after which the Si surfaces were placed in anhydrous methanol, removed from the glove-box, and sonicated for 5 min each in methanol, acetone/titrile, and water. The success of the alkylation reaction was monitored via x-ray photoelectron spectroscopy, which confirmed that the Si atop sites had been fully terminated by Si–C bonds, and indicated that the level of surface oxidation was consistently well below 0.2 ML of SiO₂.

For transport from Pasadena, CA to Chicago, IL, the samples were sealed in plastic containers under an inert atmosphere (less than 0.2 ppm O₂, 0.5 ppm H₂O) to effect minimal sample degradation.

A helium atom scattering apparatus with high-energy-resolution and momentum-resolution was used to measure the surface structure and dynamics of methylated Si(111). The apparatus has been described in detail elsewhere. Briefly, helium was expanded through a 20 μm nozzle source that was cooled by a closed-cycle helium refrigerator to generate a nearly monochromatic (Δv/v ≤ 1%) supersonic neutral atom beam. Primarily, a 46 meV beam (wave vector, k_i=9.4 Å⁻¹; nozzle temperature, T_n~213 K) was used for the experiments, while a 17.5 meV beam (k_i=5.73 Å⁻¹ and T_n~81 K) was employed for measurements of the specular angular width. A mechanical chopper modulated the helium beam with a 50% duty cycle prior to collision. The beam was collimated to 0.22° [full width at half maximum (FWHM) and impinging on the crystal (chopper-crystal distance =0.5473 m) that was housed in an ultrahigh vacuum surface-scattering chamber. The crystal was mounted on a six-axis manipulator that could be positioned precisely to control the incident angle θ_i, the azimuth φ, and the tilt χ with respect to the scattering plane. Sample temperatures ranging from 30 to 900 K were achieved by tethering a heatable crystal mount to a closed-cycle helium refrigerator. Atoms were reflected into a triply differentially pumped rotatable detector with an overall instrument resolution of 0.5° (FWHM) and were ionized by electron bombardment.
At the start of each experiment, the crystal was briefly heated to 700 K to remove any accumulated adsorbates and hydrocarbon contaminants. Previous works have demonstrated that the methyl surface moieties are stable at these temperatures, which the highly sensitive helium reflectivity measurements performed herein have confirmed. Diffraction patterns were recorded by aligning the crystal at a given incident angle $\theta_i$ and a computer-controlled motor was used to scan the detector through the final angle $\theta_f$. Typically, a beam energy of 46 meV ($k_i=9.4$ Å$^{-1}$ and $T_e=213$ K) was used, so that the diffraction peaks were observable over the full angular range of the instrument. The thermal attenuation of the elastic scattering signal was recorded over a surface temperature $T_S$ range of 200–500 K in 50 K steps. Specular, first-order, and second-order diffraction peaks were collected for each sample.

### III. RESULTS AND DISCUSSION

Methyl termination of the Si(111) surface preserves the hexagonal unit cell native to the (111) crystal face. Consistently, LEED patterns of such systems exhibit threefold symmetry with a hexagonal arrangement of the adlattice and a methyl group spacing of about 4 Å. Cryogenic STM measurements have shown the methyl-methyl separation to be 3.8 Å, which matches the spacing of the silicon underlayer. Elastic helium atom scattering provides a powerful method for determination of the surface structure and the coherence length of the surface. The beam used in this work illuminates a spot of approximately 3.7 mm in diameter, providing a macroscopic sampling of the surface. The scattering experiment is thus complementary to the local-scale structural measurements obtained by STM.

Figure 1 shows diffraction patterns collected from the CH$_3$-terminated (black) and CD$_3$-terminated (red) Si(111) surfaces at $T_S=200$ K, plotting the scattered helium intensity versus the parallel wave vector. The two diffraction patterns have been vertically offset for clarity. The incident angle was 22.7° and the azimuth was aligned along the $\langle\bar{1}2\bar{1}\rangle$ direction. The bottom axis has been transformed from the final angle $\theta_f$ to the parallel momentum transfer $\Delta K$, using the equation

$$\Delta K = k_i(\sin(\theta_f) - \sin(\theta_i)).$$

The condition for elastic diffraction is met when

$$\Delta K = h\vec{b}_1 + k\vec{b}_2,$$

where $h$ and $k$ are the diffraction indices and $\vec{b}_i$ are the reciprocal lattice vectors. Both diffraction scans were recorded in the same geometry and showed two peaks spaced equivalently from the specular reflection ($\Delta K=0$ Å$^{-1}$). These diffraction peaks appeared at $\Delta K=1.90$ and 3.80 Å$^{-1}$, corresponding to a lattice constant of 3.82 Å for both the CH$_3$- and CD$_3$-terminated Si(111) surfaces. Helium diffraction thus revealed that the terminal methyl groups have the same spacing as the native Si(111), forming a (1 x 1) structure. Minimal diffuse background further indicated long-range order and low defect density across the crystal surface.

The angular width of the specular peak was also analyzed to gain insight into the average coherence length of the surface (Fig. 2). The surface is composed of large atomically flat terraces separated by single atom steps and the size of these terraces is approximately the coherence length. The measured specular width $\Delta \theta_{\exp}$ is a convolution of the instrument function broadening $\Delta \theta_{\inst}$ and the domain size broadening $\Delta \theta_{\varphi}$, as given by

$$\Delta \theta_{\exp} = \Delta \theta_{\varphi}^2 - \Delta \theta_{\inst}^2,$$

The coherence length $l_c$ can then be determined using

$$l_c = \frac{5.54}{\Delta \theta_{\varphi} k_i \cos(\theta_i)}.$$

For the purpose of this measurement, the neutral flight path from chopper to ionizer was lengthened to 1.549 m by addition of a cylindrical spacer to the detector. The additional length of the detector narrowed the acceptance angle to 0.29° ($\sim 0.02$ Å$^{-1}$), thereby improving the overall angular resolution. Furthermore, the beam energy was lowered to 17.5 meV and mass-selected the helium ions, which were then collected by an electron multiplier.

A quadrupole filter was used to select the helium ions, which were then collected by a quadrupole filter.
meV ($k_i=5.73$ Å$^{-1}$ and $T_n=81$ K) to minimize the diffuse elastic and multiphonon contributions to the linewidth. These experimental parameters yield a maximum measurable domain size of about 900 Å. The peak in Fig. 2 was fit with two Gaussian functions to account for the narrow coherent elastic contribution (1) and for the broad diffuse elastic/multiphonon contribution (2). A FWHM of $\Delta \theta_{\text{exp}}=0.32^\circ$ was determined from the fitting procedure. The higher resolution measurements showed the average domain size of the CH$_3$-Si(111) surface to be approximately 500 Å as calculated from Eq. (4). The domain size measured in the scattering experiment roughly agrees with the 200×200 nm STM images obtained previously.\(^{30}\)

The thermal attenuation of the diffraction peaks provides atomic level insight into the surface vibrational dynamics.\(^{34,35}\) The decay of the peak intensity with increasing surface temperature (Fig. 3) occurs through the increasing vibrational amplitude of the surface oscillators. The vibrational amplitude is quantified by measurement of the peak decay with $T_S$, and by calculation of the Debye–Waller factors. The mean-square displacements (MSD) of the methyl groups both perpendicular and parallel to the surface were then extracted from the Debye–Waller factor. The Debye–Waller argument states that elastic scattering decays exponentially with temperature, as given by

$$I = I_0 e^{-2W(T_S)},$$

(5)

where $I_0$ is the peak intensity at $T_S=0$ K and $\exp[-2W(T_S)]$ is the Debye–Waller factor. The Debye–Waller factor contains contributions from perpendicular ($\Delta k_z$) and parallel ($\Delta K$) components of momentum transfer and their associated mean-square displacements as given by

$$2W = \Delta k_z^2\langle u_z^2 \rangle + \Delta K^2\langle u^2 \rangle.$$  

(6)

$\Delta K$ is given in Eq. (1) and the expression for $\Delta k_z$ is given by Eq. (7)

$$\Delta k_z = k_i \left\{ \cos^2(\theta_i) + \frac{D}{E_i} \right\}^{1/2} + \left\{ \cos^2(\theta_i) + \frac{D}{E_i} \right\}^{1/2},$$

(7)

where $E_i$ is the incident beam energy and $D$ is the He-surface attractive potential well depth, which in this expression accounts for the added acceleration of the helium atom before collision with the surface.\(^{46}\)

The decay of the specular diffraction peak intensity was measured as a function of $T_S$. Assuming that the Debye model holds across the experimental temperature range (200–500 K), the mean-square displacements of the surface oscillators should increase linearly with surface temperature. Figure 3 displays the specular ($\Delta K=0$ Å$^{-1}$) peak decay produced by heating methyl-terminated Si(111) from 200 to 500 K in steps of 50 K. Data were collected with an incident beam energy $E_i=46$ meV ($k_i=9.4$ Å$^{-1}$) at $\theta_i=\theta_f=29.7^\circ$. The inset shows the logarithm of the numerical peak integrals as a function of the surface temperature. A linear decay was observed for the system over the experimental range, consistent with the Debye model. The temperature coefficient of the perpendicular mean-square displacement was extracted from the thermal decay and, for simplicity, will be called the perpendicular MSD.

Equation (6) can be modified to include the temperature dependence of the Debye–Waller exponent

$$\sigma_{ijk} = -\frac{d(2W)}{dT} = -\left[ \frac{\Delta k_z^2 d\langle u_z^2 \rangle}{dT} + \Delta K^2 d\langle u^2 \rangle \right].$$

(8)

The variable $\sigma$ indicates the decay rate with the first index, either H or D, specifying CH$_3$ or CD$_3$ termination, and the last two indices designating the specific diffraction peak. For example, $\sigma_{100}$ symbolizes the specular peak decay for the methyl-terminated surface. Cooling experiments were also performed, and no thermal hysteresis was observed for either CH$_3$–Si(111) or CD$_3$–Si(111) systems. The presented data were collected by heating the crystals in 50 K increments.

To accurately quantify the perpendicular mean-square displacements, the normal component of momentum transfer must be fully characterized. As shown in Eq. (7), the perpendicular momentum transfer depends on $\cos^2 \theta_i$ and on the well depth $D$, which is unknown for this system. For the specular geometry ($\theta_i=\theta_f$), Eq. (7) reduces to

$$\Delta k_z^2 = 4k_i^2 \left[ \cos^2(\theta_i) + \frac{D}{E_i} \right].$$

(9)

Figure 4 displays the specular decay for the methyl-terminated surface in (a) and for the CD$_3$-terminated surface in (b). The data were recorded with a 46 meV beam at incident angles of 36.2$^\circ$ (black circles), 29.7$^\circ$ (red squares), and 22.7$^\circ$ (blue diamonds). The specular decay rates can be linearized with respect to $\cos^2 \theta_i$, as given by

$$\sigma_{00} = -a \cos^2(\theta_i) - b,$$

$$a = 4k_i^2 \frac{d\langle u_z^2 \rangle}{dT},$$

$$b = a \frac{D}{E_i}.$$  

(10)

A fit of the data provided the perpendicular mean-square displacement from the slope and the well depth from the intercept. In Fig. 5, $\sigma_{100}$ and $\sigma_{00}$ are shown in black circles and red squares, respectively, with the error bars representing...
and the well depths, respectively. The CD$_3$–Si(111) surface exhibited a perpendicular MSD that was about 20% greater than the CH$_3$–Si(111) surface as expected from the isotopic substitution. The well depths determined from the intercepts were $D_H = 7.5 \pm 2.6$ meV and $D_D = 6.0 \pm 3.9$ meV, which are in agreement with other methyl-terminated systems.$^{47}$ We note that the well depths are equal within the precision of the measurement, as expected, since isotopic substitution does not alter the He-surface attractive potential. In subsequent sections, unless otherwise stated we will use the experimentally determined values of the well depth, noting that the use of the average value of 6.75 meV changes the results of our calculations by less than 5%.

A thorough discussion of the mean-square displacements requires the use of information on the CH$_3$–Si(111) normal modes and their respective vibrational frequencies, as determined by TIRS and HREELS. The methyl-Si group contains four vibrational modes: the C–Si stretching mode, the C–Si bending mode, the CH$_3$ rocking mode, and the C–Si rotational mode. The stretching and bending modes have been measured by HREELS to have frequencies of 678 and 507 cm$^{-1}$, respectively. The rocking mode has been measured by both techniques, with frequencies observed at 757 cm$^{-1}$ by TIRS and at 789 cm$^{-1}$ by HREELS. Finally, the rotational mode has not been observed but is expected from gas-phase spectra of methylsilane to have an excitation energy of about 200 cm$^{-1}$ and a rotational barrier of $\sim 590$ cm$^{-1}$. To our knowledge, the spectrum of the CD$_3$-terminated surface has not been recorded, but the additional mass expected to lower the vibrational frequencies based on gas-phase spectroscopy of isotopically substituted methylsilanes.$^{39}$

The perpendicular mean-square displacements arise from vibrational motion normal to the crystal surface. A useful first comparison can be made with the Si(111)–(7 × 7) reconstructed surface.$^{30}$ By extrapolation, the perpendicular mean-square displacement from this surface is $\sim 2 \times 10^{-3}$ Å$^2$ K$^{-1}$, about double the value for the methyl-terminated Si(111) reported herein. In the harmonic limit of the Debye model, the MSD is proportional to the inverse of mass and to the inverse square of the Debye temperature $\theta_D$. The reduction in MSD can thus be attributed to a decrease of the effective surface mass from 28 to 15 amu and to an increase in the effective Debye temperature $\theta_D$. The contribution from a change in the surface Debye temperature is discussed below.

A comparison of these data to the properties of other surfaces that have methyl termination can elucidate the most important vibrational modes associated with the measured Debye–Waller factors. For example, a methyl-terminated organic crystal, guanidinium methanesulfonate, investigated by Scoles and co-workers$^{47,51}$ showed a perpendicular MSD of about $3 \times 10^{-4}$ Å$^2$ K$^{-1}$. The difference between the methyl-terminated Si(111) and the organic crystal stems from the type of motion involved in each system. The perpendicular surface motion for the organic crystal is a low-energy mode involving a shear vertical motion of the entire guanidinium sulfonate sheet. The perpendicular MSDs of various chain
length SAMs have been measured and the thermal motion in the z-direction of such systems is about an order of magnitude greater than for CH$_3$-terminated Si(111), even though both systems project terminal methyl groups. For alkanethiol SAMs, low-energy libational modes of the whole chain are the primary contributors to the measured mean-square displacements. Hence, the stiffness of the methyl-terminated Si(111) arises from the rigidity of the directional, sp$^3$-hybrid Si–C covalent bonding in such systems.

Helium-surface attractive potential well depths can be estimated from the plethora of examples available for surfaces that are similar to methyl-terminated Si(111). The two experimental values determined herein are not statistically different from each other due to the large uncertainty in this type of indirect measurement. Bound-state resonances are a more precise method for evaluating the well depths, and the next two examples were measured using that technique. Using helium scattering from a hydrogen-terminated Si(111) surface, Allison and co-workers determined the attractive well depth to be 7.5 meV. The well depth of the methyl-terminated organic crystal was found to be 6.7 meV. Well depths for a variety of alkanethiol self-assembled monolayers that possess terminal methyl groups have been calculated and the results range from 6.8 to 8.1 meV depending on odd/even effects of the alkane chain length. The average well depth of 6.75 meV for He–CH$_3$–Si(111) is thus in excellent agreement with that reported for other, similar systems.

Once the well depths and decay rates have been determined, an expression for the Debye–Waller exponent can be used to calculate the effective surface Debye temperature $\theta_D$. The effective surface Debye temperature for molecular adlayers describes the dynamic motion normal to the surface and thus describes the stiffness of the layer. For the specular scattering geometry, and assuming that $T_S$ is of the order of the Debye temperature, the decay rate can be written as:

$$\sigma_{00} = \frac{24m(E_x \cos^2(\theta) + D)}{M_{eff}k_BT_D},$$

where $m$ is the particle mass, $M_{eff}$ is the effective surface mass, and $k_B$ is Boltzmann’s constant. Recently, the surface dynamics of silica glass were measured by HAS and the effective surface mass was determined to be 18 amu. This effective mass roughly matches the hydroxyl termination of the silica surface giving us confidence in assuming the effective mass of the CH$_3$–Si(111) surface to be 15 amu. The surface Debye temperature $\theta_D$ was determined to be 983 ± 31 K (683 cm$^{-1}$) using the experimentally determined well depth of 7.5 ± 2.6 meV and assuming $M_{eff}$ = 15 amu for CH$_3$. Likewise, $\theta_D$ = 824 ± 40 K (573 cm$^{-1}$) was calculated by using $D_p$ = 6.0 ± 3.9 meV and $M_{eff}$ = 18 amu for CD$_3$–Si(111). The uncertainty in the Debye temperature calculations results primarily from the imprecision of the experimentally determined well depths. Both terminations should have the same interaction potential with helium, as isotopic substitution does not alter the van der Waals attraction. Taking the average well depth (i.e., $D$ = 6.75 meV), the calculated Debye temperature of the methyl-terminated surface decreases slightly to 974 K, while the value for the CD$_3$–Si(111) surface increases to 832 K (changes of less than 1%).

The Debye temperature for bulk silicon is 645 K and the surface Debye temperature for Si(111) has been estimated to be 476 K. Typically, surfaces have lower Debye temperatures than bulk crystals because of the reduced dimensionality and the decrease in the phonon frequencies at the interface. Moreover, the effective Debye temperatures of a variety of organic adlayers and thin films have been measured and the materials are generally described as soft (i.e., small $\theta_D$). In contrast to typical organic films, the ordered benzene rings of a biphenyldimethylthiol film on a gold substrate created an extraordinarily stiff lattice, with an experimentally measured Debye temperature of 1397 K. The rigidity was comparable to in-plane graphite motion ($\theta_D$ ~ 1600 K) and has been ascribed to both the stiffness of the benzene ring itself and to the $\pi$-$\pi$ alignment between adjacent rings. Collectively, these results have demonstrated that the effective Debye temperature is sensitive to the local chemical and structural environments.

For the CH$_3$-terminated surface, $\theta_D$ increased by over 300 K relative to bulk Si, suggesting that rigidity is imposed by the presence of higher frequency modes. HREELS measurements showed the energy of the Si–C stretching mode to be about 680 cm$^{-1}$ (980 K), which matches the value determined by the HAS experiment. By the selection rules of the specular geometry ($\Delta K$ = 0 Å$^{-1}$), the detected helium atoms can only interact with z-polarized modes during the collision. Although a strong momentum mismatch is present between the helium atom and the Si–C vibration, the agreement between the surface Debye temperature and the Si–C vibrational frequency indicates a coupling between helium and the Si–C stretching mode. Given our observation of helium atom interaction with localized molecular modes and not the phonons of the underlying silicon lattice, a consistent explanation of the data is that the displacement field at the surface is dominated by the adsorbate layer vibrations in the perpendicular direction.

Examination of the Debye temperature of the CD$_3$-terminated Si(111) surface supports the argument advanced above. As expected, the greater mass of Si–CD$_3$ relative to Si–CH$_3$ produces a decrease in the effective Debye temperature. The gas-phase Si–CH$_3$ stretch is 700 cm$^{-1}$ for CH$_3$SiH$_3$, which is close to the 683 cm$^{-1}$ frequency observed for the CH$_3$–Si(111) surface. When additional mass is added to the silane group by substituting the hydrogens bound to silicon with deuterium (i.e., CD$_3$SiD$_3$), the Si–C stretch frequency is further decreased by an additional 81 cm$^{-1}$, to 619 cm$^{-1}$. Considering that each surface silicon atom is bound to three other silicon atoms in the lattice, the observed frequency reduction of about 110 cm$^{-1}$ is thus reasonable and comparable to that observed for gas-phase silanes.

The perpendicular MSDs can be explained by accounting for the sharp increase in effective Debye temperature in conjunction with the reduction in surface mass. Comparing methyl-terminated Si(111) to Si(111)–(7×7), the mass is
bending modes with the near-surface phonons of the silicon underlayer, which could potentially contribute to the observed enhancement of the parallel MSDs relative to the perpendicular displacements.\textsuperscript{60} For comparison, Sciles and co-workers\textsuperscript{31} measured a parallel MSD of 5.0 \times 10^{-4} \text{Å}^2 \text{K}^{-1} for the methyl-terminated organic crystal. Furthermore, a 21-carbon chain alkanethiol exhibited a parallel MSD of 7.2 \times 10^{-4} \text{Å}^2 \text{K}^{-1}.\textsuperscript{7} This order of magnitude for the parallel thermal motion thus seems to describe a variety of methyl surface groups.

The vibrational dynamics of bare silicon surfaces are dominated by surface phonons, while soft molecular modes are the main contributors to the dynamics of interfaces functionalized with organic adlayers. Our results have revealed that the thermal motion of the methyl-terminated surface is similar to a rigid semiconductor in the normal direction and is like that of an alkanethiol SAM in the surface plane. The addition of a single carbon alkyl group is thus sufficient to drive the transition from phonon-dominated dynamics to a regime in which the motion is governed by local molecular modes.

IV. CONCLUSION

Helium atom diffraction has provided information on the surface structure, gas-surface interaction potential, and vibrational dynamics of CH$_3$- and CD$_3$-terminated Si(111) surfaces. Methylation of the silicon surface generates large domains while preserving the native structure of the underlayer. Using the angular dependence of the temperature-induced specular decay, the He-surface potential well depths and Debye temperatures have been estimated for both surfaces. The thermal motions of the alkyl groups both perpendicular and parallel to the surface have been quantified by determination of the mean-square displacements. Elastic scattering decay occurs primarily through coupling between helium atoms and Si–CH$_3$ molecular vibrations upon collision. In summary, we have probed the vibrational dynamics of this technologically relevant surface, providing complementary information to the well-studied static properties of these interfaces.

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\begin{thebibliography}{99}
\bibitem{9} F. Schreiber, A. Eberhardt, T. Y. B. Leung, P. Schwartz, S. M. Wetterer,
\end{thebibliography}